

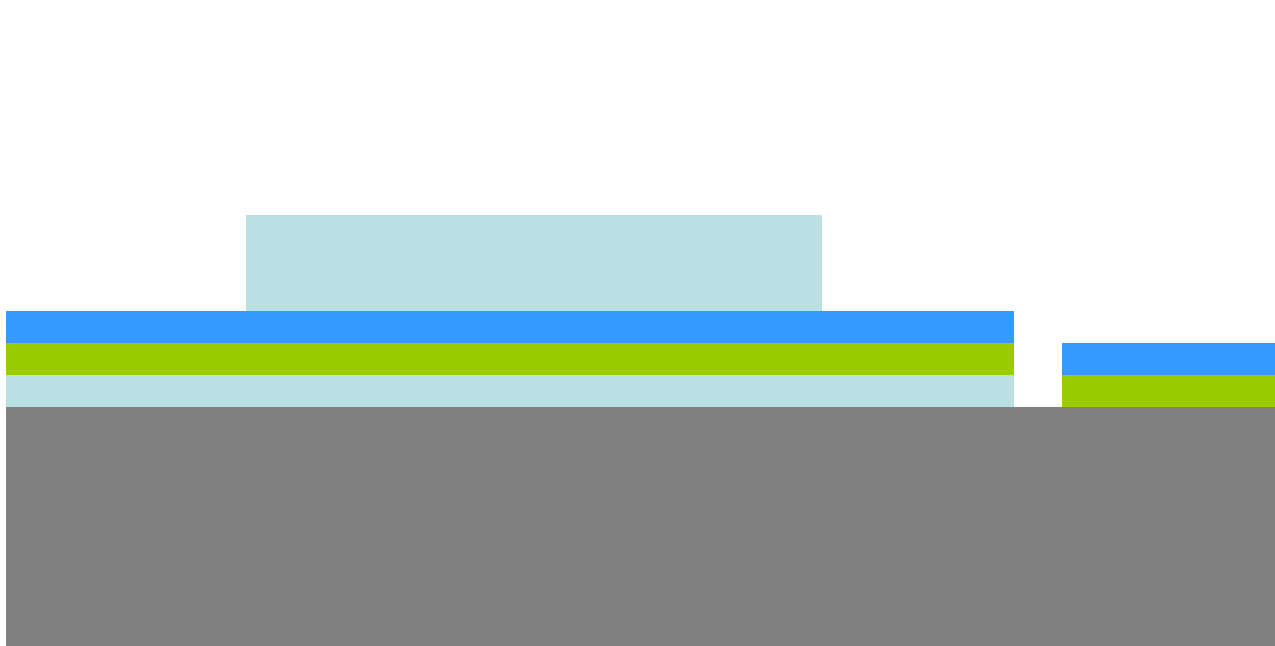
Grow thermal oxide and etch  
Deposit nitride



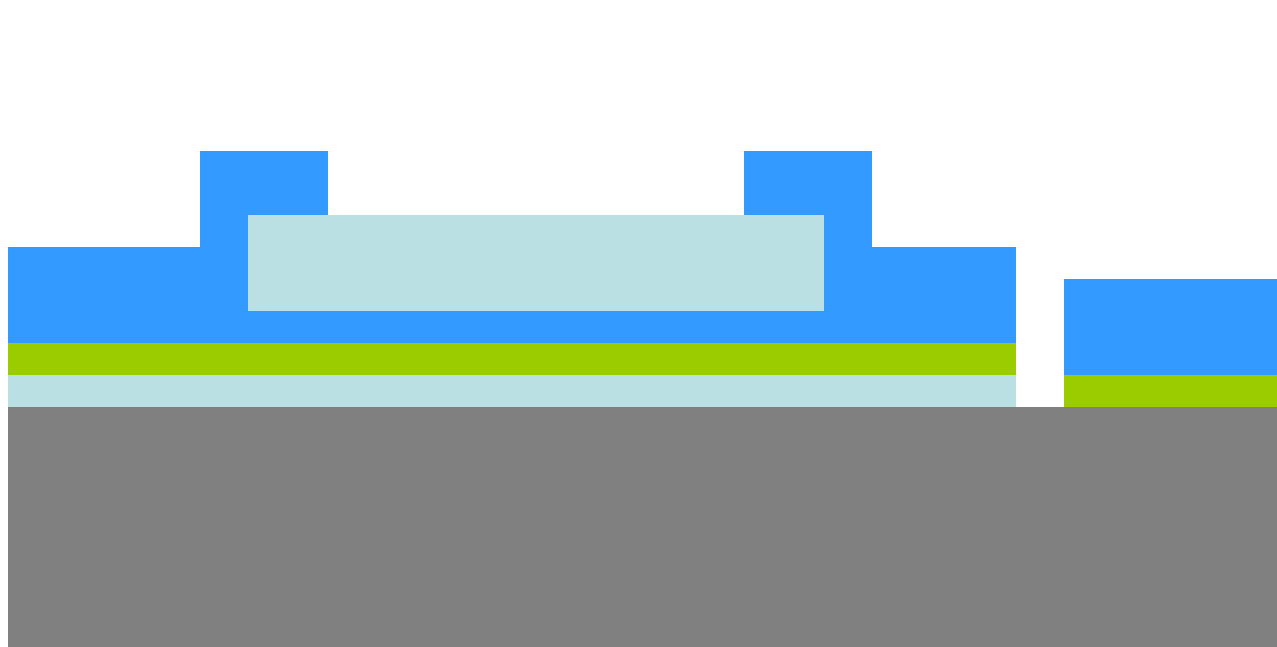
Etch nitride  
Deposit poly0



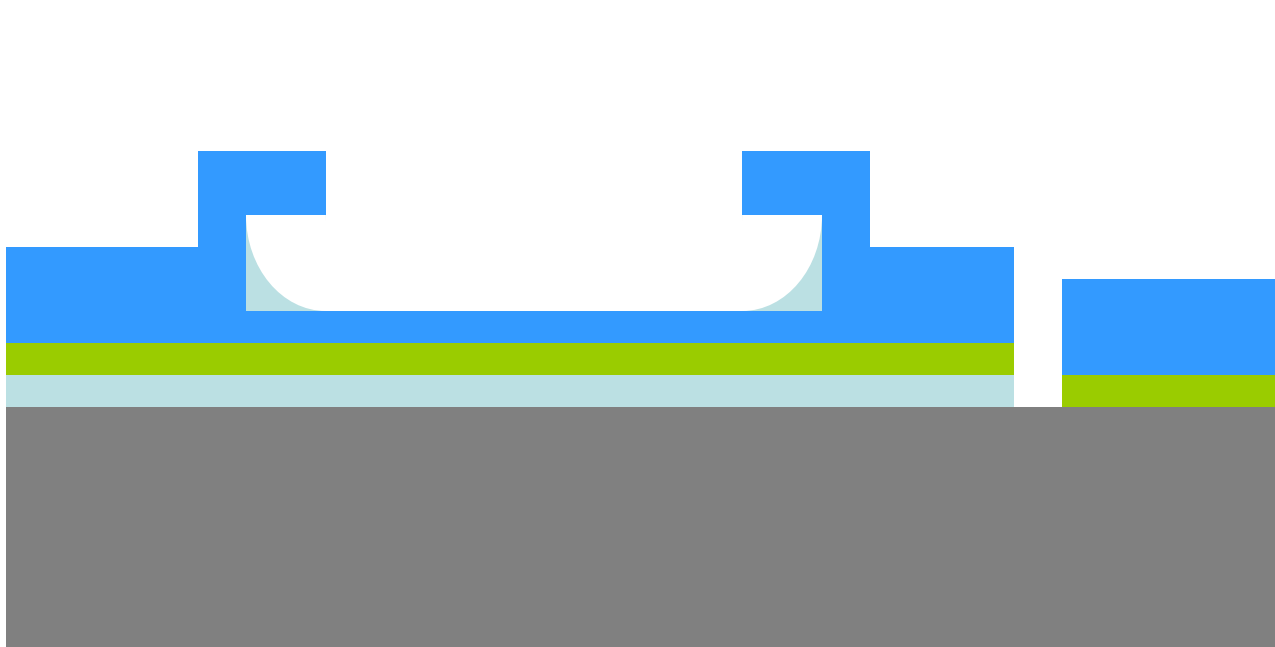
Etch poly0  
Deposit and etch oxide1



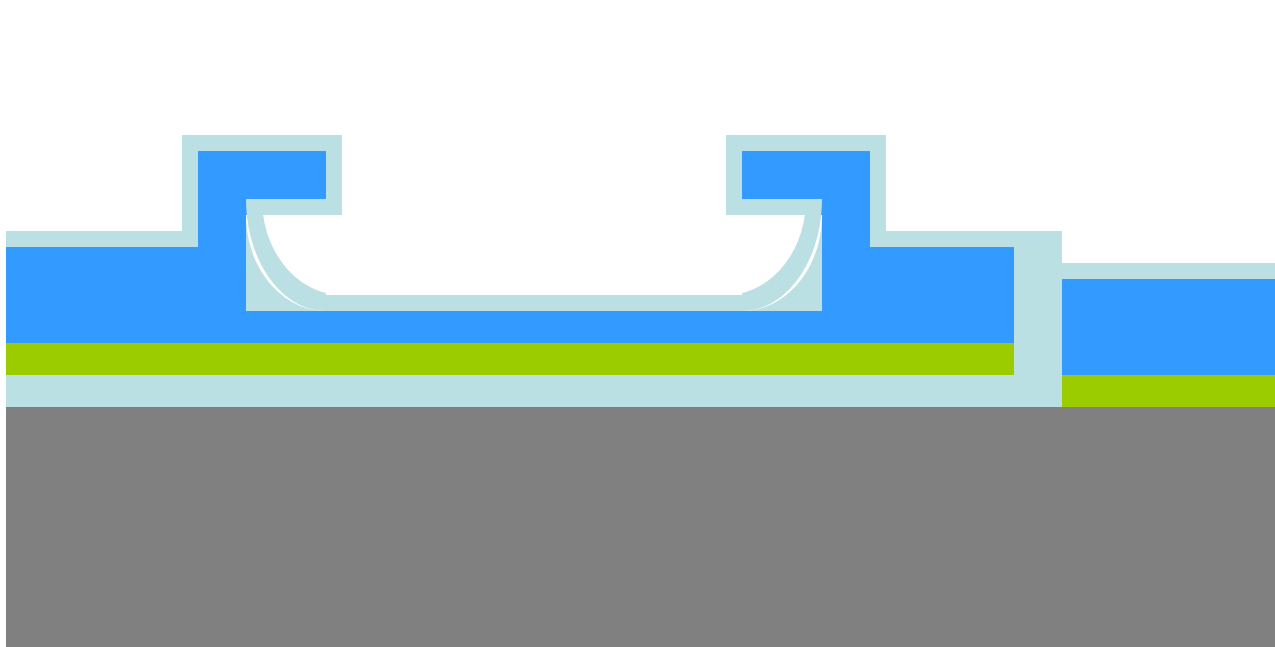
## Deposit and etch poly1



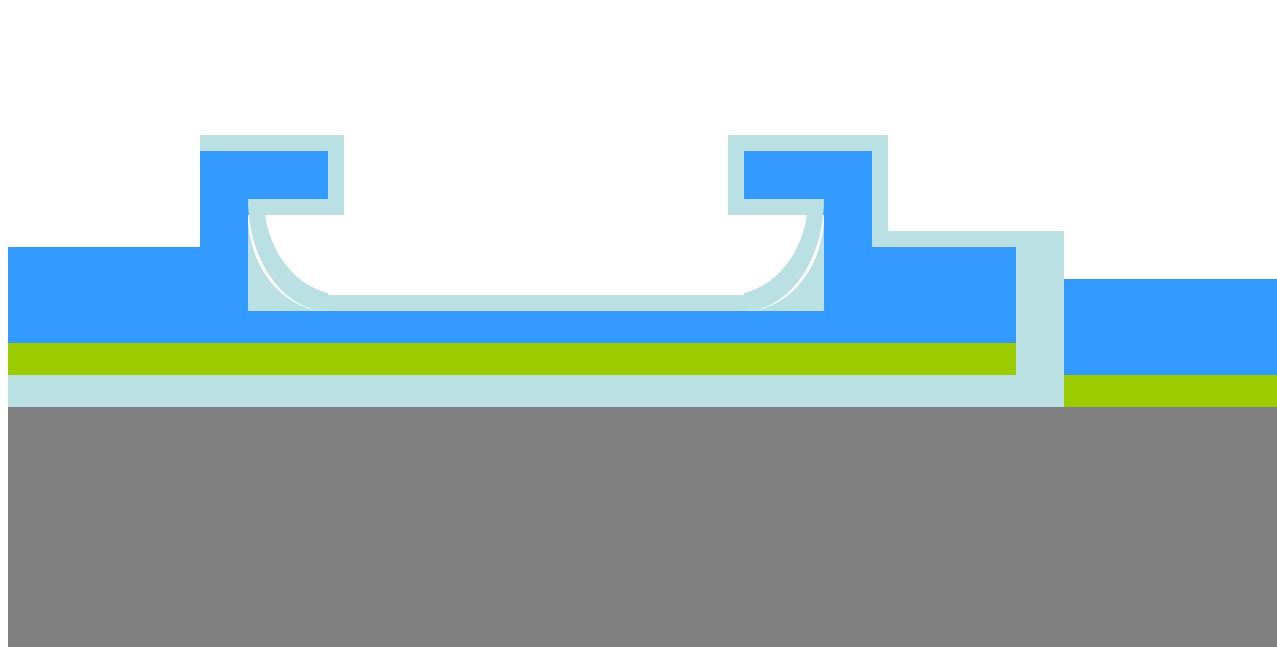
## Isotropic etch of oxide1



Deposit oxide2

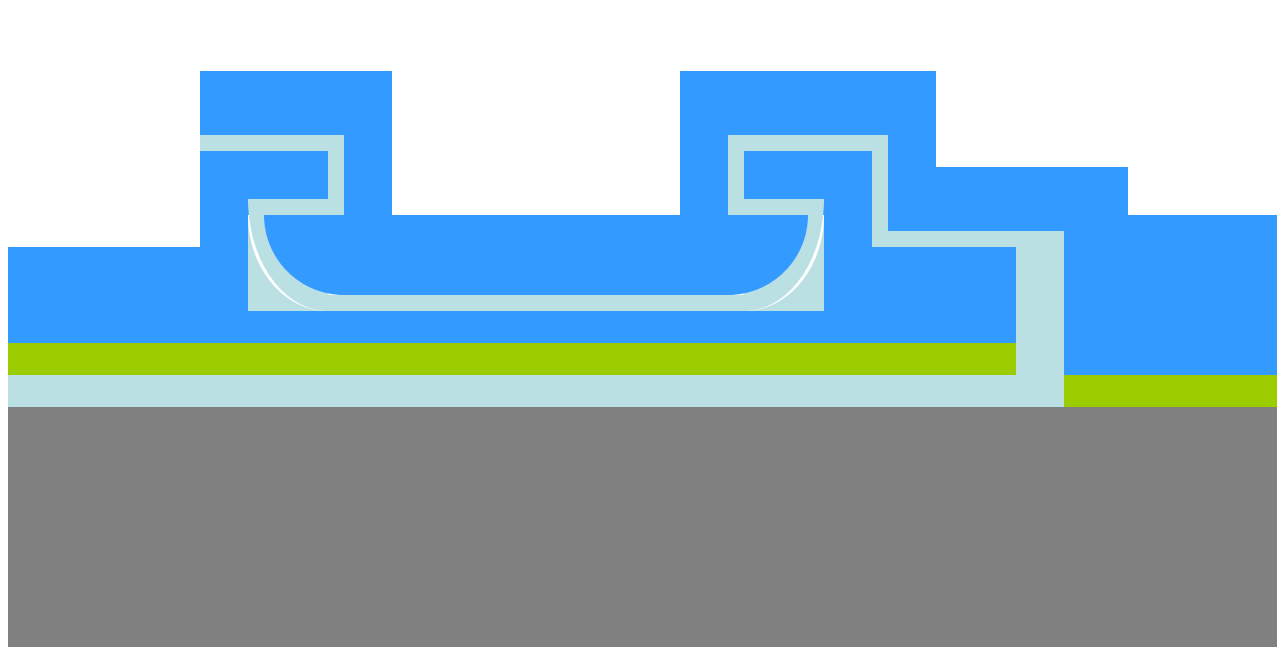


Etch oxide2





## Deposit and etch poly2



Sacrifice thermal oxide, oxide1, and oxide2

